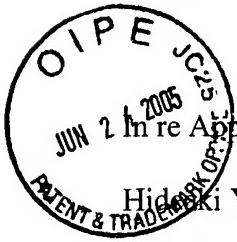


Docket No.: 060188-0719

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Hidetoshi YOSHIDA
Application No.: 10/718,607

: Customer Number: 20277
: Confirmation Number: 1705
: Group Art Unit: 2822
: Examiner: TRINH, Michael Manh

For: CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of May 27, 2005 wherein restriction has been required,
Applicant hereby elects Group I (claims Claims 1-7) for prosecution in the above-identified
application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is
hereby made. Please charge any shortage in fees due in connection with the filing of this paper,
including extension of time fees, to Deposit Account 500417 and please credit any excess fees to
such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty
Registration No. 36,139
**Please recognize our Customer No. 20277
as our correspondence address.**

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 MEF:dmd
Facsimile: 202.756.8087
Date: June 24, 2005

WDC99 1100314-1.060188.0719